

10/551484

PATENT
930086-2015

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Beyong-Hwan RYU, Ki-Jeong KONG, Hyun-Ju CHANG,
Young-Min CHOI, Jae-do LEE, Ha-Kyun JUNG,
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Serial No. : Not Yet Assigned

For : METHOD OF PREPARING CARBON NANOTUBE
FROM LIQUID PHASED-CARBON SOURCE

Filed : Not Yet Assigned

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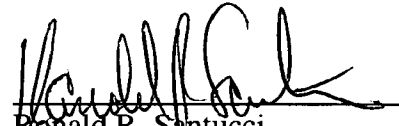
The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application; within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; or before the mailing date of a first Office Action on the merits, whichever event occurs last. No fee is required.

The filing of this Information Disclosure Statement is not an admission that the documents identified herein constitute prior art to the present application.

The Commissioner is authorized to charge any additional fee that may be required to Deposit Account No. 50-0320.

Respectfully submitted,
FROMMER LAWRENCE & HAUG LLP

By:


Ronald R. Santucci
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| Based on Form PTO-1449 (3/90) LIST OF REFERENCES CITED BY APPLICANT (Use several sheets if necessary) | ATTY. DOCKET NO. 930086-2015 | SERIAL NO. 10/551484 To Be Assigned |
| | APPLICANT Beyong-Hwan RYU, et al. | |
| | FILING DATE To Be Assigned | GROUP To Be Assigned |

U.S. PATENT DOCUMENTS

| EXAMINER INITIAL | | DOCUMENT NUMBER | DATE | NAME | CLASS | SUBCLASS | FILING DATE IF APPROPRIATE |
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| | AH | | | | | | |
| | AI | | | | | | |
| | AJ | | | | | | |
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FOREIGN PATENT DOCUMENTS

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| | AT | | |
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| EXAMINER /Stuart Hendrickson/ | DATE CONSIDERED 09/16/2009 |
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